

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Atsushi KUROKAWA et al.

Appln. No.:

Filed: HERewith

For: METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE

\* \* \*

PRELIMINARY AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Prior to examination, please amend the above-identified patent application as indicated below.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks begin on page 9 of this paper.